

IOAP 4.1-1
Preliminary to First Office Action
Amdt. dated February 10, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : Confirmation No.

Applicants : Anatoly Leontievich Vikharev, Aleksey
Mikhaylovich Gorbachev, Aleksandr
Grigorievich Litvak, Juriy Vladmirovich
Bykov, Grigory Gennadievich Denisov,
Oleg Andreevich Ivanov and Vladimir
Aleksandrovich Joldanov

Filed :

TC/A.U. :

Title : HIGH VELOCITY METHOD FOR DEPOSITING
DIAMOND FILMS FROM A GASEOUS PHASE IN
SHF DISCHARGE PLASMA AND A PLASMA
REACTOR FOR CARRYING OUT SAID METHOD

Docket No. : IOAP 4.1-1

Customer No.: 21036

MAIL STOP AMENDMENT
Commissioner For Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

PRELIMINARY AMENDMENT UNDER 37 CFR 1.111

Sir:

Prior to the first Office Action, Applicants
amend and remark as follows:

Amendments to the Claims are reflected in the Listing of
Claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.